

JAN 11 2007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hong-Jyh Li, et al. Examiner: Quoc Dinh Hoang
Serial No.: 10/799,910 Group Art Unit: 2818
Filed: March 12, 2004 Docket No.: 2004P50029US/1331.135.101
Title: ION IMPLANTATION OF HIGH-K MATERIALS IN SEMICONDUCTOR
DEVICES

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

PETITION FOR ONE-MONTH EXTENSION OF TIME

It is requested that the time for filing the Response, which is in reply to the Office Action mailed August 11, 2006, having a three-month response date of November 11, 2006, be extended to January 11, 2007.

The Patent Office is hereby authorized to charge Deposit Account 500471 in the amount of \$450.00 to cover the Extension of Time Fee as set for under 37 C.F.R. § 1.17(a)(1).

Respectfully submitted,

Hong Jyh Li, et al.,

By their attorneys,

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Dated: January 11, 2007
SED:kmh

Steven E. Dicke
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CERTIFICATE UNDER 37 C.F.R. 1.8:

The undersigned hereby certifies that this paper or papers, as described herein, are being transmitted via facsimile to Facsimile No. (571) 273-8300 on this 11th day of January, 2007

By: Steven E. Dicke
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